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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Applicant: Kaiping Liu

Docket Number: TI-34717.1

Serial No.: **10/785,623**

Art Unit: 2891

Filed: 02/24/04

Examiner: Chandra P. Chaudhari

For: Method to Produce Localized Halo for MOS Transistor

**CERTIFICATION OF FACSIMILE TRANSMISSION**

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Karen Vertz  
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**FACSIMILE COVER SHEET**

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NAME OF INVENTOR(S):	
Kaiping Liu	
RECEIPT DATE & SERIAL NO.:	
<b>Serial No.: 10/785,623</b>	
Filing Date: 02/24/04	
TI FILE NO.:	DEPOSIT ACCT. NO.:
<b>TI-34717.1</b>	<b>20-0668</b>
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Texas Instruments Incorporated  
PO Box 655474, M/S 3999  
Dallas, TX 75265-5474

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In re the Application of: Kaiping Liu

Docket No.: TI-34717.1

Serial No.: 10/785,623

Art Unit: 2891

Filed: 02/24/2004

Examiner: Chaudhari, C.

Title: Method to Produce Localized Halo for MOS Transistor

**AMENDMENT UNDER 37 CFR §1.116**

March 8, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Karen Vertz  
Karen Vertz

3-8-06  
Date

Dear Commissioner:

In response to the Office Action, dated 12/16/2005, in the above-identified patent application, please make the following amendments. They are respectfully submitted as a full and complete response to that Action. Charge any required fees to the deposit account of Texas Instruments Incorporated, Account No. 20-0668.